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Information Disclosure Citation to an Application		Docket Number		Group Art Unit		Filing Date		
		068758.0178		2832		March 10, 2004		
U.S. PATENT DOCUMENTS								
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
Am	1	5,279,988	01-18-94	Saadat et al.	437	195	03-31-92	
Am	2	5,609,946	03-11-97	Korman et al.	428	209	10-03-95	
Am	3	5,998,048	12-07-99	Jin et al.	428	694	03-02-98	
Am	4	6,008,102	12-28-99	Alford et al.	438	381	04-09-98	
Am	5	6,103,405	08-15-00	Tomita	428	692	02-03-98	
FOREIGN PATENT DOCUMENTS								
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
Am	6	DE101 04 648 A1	01-31-02	GERMANY	H01F	17/04		x
Am	7	EP 0 684 616 A1	05-17-95	EPO	H01F	17/00	x	
Am	8	EP 0 725 407 A1	01-23-96	EPO	H01F	17/00	x	
Am	9	57111006	07-10-82	JAPAN	H01F	15/00	Abstract	
NON-PATENT DOCUMENTS								
		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					DATE	
Am	10	J.A. Power et al., "An investigation of On Chip Spiral Inductor on .06 $\mu$ m BiCMOS technology for Application"; IEEE Int. Conf. on Microelectronic Test Structures, Vol. 12, pp. 18-23					1999	
Am	11	A. Gromov et al., "A Model for Impedance of Planar RF Inductors Based on Magnetic Films"; IEEE Transactions on Magnetics, Vol. 34, No. 4, pp. 1246-48					July 1998	
Am	12	M. Yamaguchi et al., "Characteristics and Analysis of a Thin Film Inductor with Closed Magnetic Circuit Structure"; IEEE Transactions on Magnetics, Vol. 28, No. 5, pp. 3015-17					September 1992	
Am	13	T. Inoue et al., "The Effect of Magnetic Film Structure on the Inductance of a Planar Inductor"; IEEE Transactions on Magnetics, Vol. 34, No. 4, pp. 1372-74					July 1998	
Am	14	Park, J.Y., et al.; "Batch-Fabricated Microinductors with Electroplated Magnetically Anisotropic and Laminated Alloy Cores; IEEE Transactions on Magnetics, Vol. 35, No. 5, pp. 4291-4300					1999	
Am	15	Nose, M., et al.; "Domain Structures and High-Frequency Response of Magnetization for CoNBZR Stripe Films"; IEEE Translation Journal on Magnetics; pp. 59-66					1994	
EXAMINER					DATE CONSIDERED			
Am					10/8/04			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.								